

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of  
ANTONIUS H.M. RAAIJMAKERS ET AL

Atty. Docket  
PHN 17,819

Serial No. 09/745,914

Group Art Unit:

Filed: DECEMBER 22, 2000

Examiner:

Title: ELECTRO-OPTICAL HAVING AN ITO LAYER, A SIN LAYER AND AN  
INTERMEDIATE SILICON OXIDE LAYER

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.97

Sir:

Enclosed is a Form PTO-1449 and copies of documents listed thereon. These documents are considered to be relevant in that they have been:

- ☐ considered in drafting the specification of the above-referenced application;
- ☐ cited in the specification of the above-referenced application; or
- ☒ cited as an "X" or "Y" document in a foreign Patent Office search report on a foreign counterpart application a copy of which report is also enclosed.

☐ I hereby certify that these documents were cited in said search report not more than three (3) months ago

☐ Please charge any fee under 1.17(p) for this Information Disclosure Statement to be considered, not exceeding \$240.00, to Account No. 14-1270.

If readily available, English-language counterparts have been substituted for foreign-language patent documents. This disclosure is not an admission that any of these documents is material to or even prior art with respect to the above-referenced application.

Respectfully submitted,

By *Aaron Waxler*  
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CERTIFICATE OF MAILING

It is hereby certified that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to:

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On June 5, 2001

By *Valerie Dean*

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